

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Group Art Unit: 2112
	)	
<b>Shinichiro Nohdo</b>	)	Examiner: <b>Rebecca Slomski</b>
	)	
Application No. 10/812,602	)	Confirmation No. 3173
	)	
Filed: <b>March 30, 2004</b>	)	
	)	
For: WAFER, EXPOSURE MASK, METHOD OF	)	
DETECTING MARK AND METHOD OF	)	
EXPOSURE	)	

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT  
BEFORE MAILING DATE OF EITHER A FINAL OFFICE ACTION  
OR NOTICE OF ALLOWANCE (37 C.F.R. § 1.97(C))**

**TIME OF TRANSMITTAL OF ACCOMPANYING  
INFORMATION DISCLOSURE STATEMENT**

The identified were references cited in a Communication issued on April 20, 2007, for counterpart European Patent Application No. 04007823.0 - 2222. A copy of the communication is submitted herewith.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 C.F.R. § 1.97 (g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner.

Transmittal of Information Disclosure Statement

Page 2

Applicant submits herewith a payment via the electronic submission process in the amount of \$180.00, the fee set forth in 37 C.F.R. § 1.17(p) for submission of an information disclosure statement under § 1.97 (c).

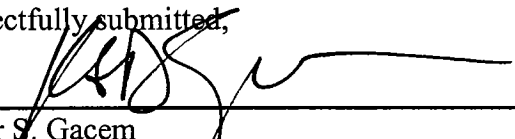
The Commissioner is hereby authorized to credit overpayments or to charge any deficiency in a required fee not already covered by the credit card payment to Deposit Account No. 19-3140.

Dated:

05/24/07

By:

Respectfully submitted,

  
\_\_\_\_\_

Kader S. Gacem

Registration No. 52,474

SONNENSCHNEIN NATH & ROSENTHAL LLP

P.O. Box 061080

Wacker Drive Station, Sears Tower

Chicago, Illinois 60606-1080

(312) 876-8000